

Notice of References Cited

Application/Control No.

10/804,171

Applicant(s)/Patent Under
Reexamination
CHO ET AL.

Examiner

Douglas J. Duff

Art Unit

3748

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,132,177	10-2000	Loprete et al.	417/221
*	B	US-2002/0051715 a1	05-2002	Matsumoto et al.	417/410.3
*	C	US-5,006,051	04-1991	Hattori, Hitoshi	418/60
*	D	US-5,322,424	06-1994	Fujio, Katuhara	418/11
*	E	US-6,024,547	02-2000	Nagae, Koji	418/11
*	F	US-6,190,137	02-2001	Robbins et al.	417/221
*	G	US-4,248,053	02-1981	Sisk, Francis J.	62/158
*	H	US-4,236,874	12-1980	Sisk, Francis J.	417/315
*	I	US-6,092,993	07-2000	Young et al.	417/53
*	J	US-5,780,990	07-1998	Weber, Harold J.	318/807
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.